

Notice of References Cited	Application/Control No. 10/789,272		Applicant(s)/Patent Under Reexamination JIN ET AL.	
	Examiner JOHN LEE		Art Unit 2624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,175,379 B1	01-2001	Uomori et al.	348/47
*	B	US-2002/0024516 A1	02-2002	Chen et al.	345/419
*	C	US-2003/0113018 A1	06-2003	Nefian et al.	382/181
*	D	US-2003/0197779 A1	10-2003	Zhang et al.	348/14.16
*	E	US-2004/0189720 A1	09-2004	Wilson et al.	345/863
*	F	US-2004/0193413 A1	09-2004	Wilson et al.	704/243
*	G	US-7,224,357 B2	05-2007	Chen et al.	345/420
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.